

UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S) Dharmesh Jawarani et al GROUP ART UNIT: 2813
APPLN. NO.: 10/718,892 EXAMINER: Heather Anne Doty
FILED: November 21, 2003
TITLE: SEMICONDUCTOR DEVICE WITH SILICIDED SOURCE/DRAINS

Certificate of Submission

I hereby certify that this correspondence is being submitted to the U.S.P.T.O., Alexandria, VA.

- ☐ Addressed per C.F.R. § 1.1(a) and deposited with the United States Postal Service with sufficient postage as first class mail.
- ☐ Facsimile transmitted in accordance with C.F.R. § 1.6(d).
- ☒ Submitted electronically via EFS in accordance with "Legal Framework for EFS Web".

10-24-06
Date of Submission

/Stacie Herrera/
Signature

Stacie Herrera
Printed Name of Person Signing Certificate

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action dated July 31, 2006, and Examiner's comments with regard thereto, please enter the following amendments in the above-entitled application, without prejudice or disclaimer.

If Applicant has overlooked any additional fees, or if any overpayment has been made, the Commissioner is hereby authorized to credit or debit Deposit Account 503079.